



PATENT
97-CCP-251 DIV

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
ERIC GERRITSEN, et al.) Group Art Unit: 2813
Serial No.: 09/858,400)
Filed: May 16, 2001) Examiner: T. Nguyen
For: PROCESS FOR FORMING A LOW)
RESISTIVITY TITANIUM SILICIDE)
LAYER ON A SILICON SEMICON-)
DUCTOR SUBSTRATE (As Amended))

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with Rule 1.136, Applicants respectfully petition the Commissioner for an extension of time extending to March 26, 2004, the period for response to the Office Action dated September 26, 2003. Please charge Deposit Account No. 50-1556 in the amount of \$950.00 to cover the extension fee.

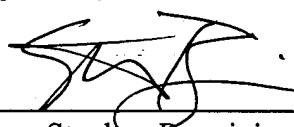
If it should be determined that a longer extension is required to prevent this application from becoming abandoned, or for any other reason an insufficient fee has been paid, please charge any insufficiency to Deposit Account No. 50-1556.

04/07/2004 GWORDDF1 00000011 501556 09858400

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Date: March 26, 2004

Respectfully submitted,

By: 
Stephen Bongini
Registration No. 40,917

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450.


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3/26/04
Date of Deposit